

Title (en)

METHOD AND DEVICE FOR COATING SUBSTRATES FROM THE VAPOR PHASE

Title (de)

VERFAHREN UND VORRICHTUNG ZUR BESCHICHTUNG VON SUBSTRATEN AUS DER DAMPFPHASE

Title (fr)

PROCÉDÉ ET DISPOSITIF DE REVÊTEMENT DE SUBSTRATS À PARTIR DE LA PHASE VAPEUR

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Application

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Abstract (en)

[origin: WO2011026971A1] The invention relates to a method for coating substrates (1) with materials to be vaporized in a vacuum coating system, wherein the vaporization material is deposited on the substrate (1) by double vaporization using an intermediate carrier (3), wherein the intermediate carrier (3) is continuously moved. The aim of the invention is to provide an intermediate carrier that ensures the application in a flow-through coating system. This aim is achieved according to the invention by a cylindrical intermediate carrier (3).

IPC 8 full level

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